

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Osamu S. Nakagawa et al.

Confirmation No.: 3635

Application No.: 09/891,324

Examiner: Schillinger, Laura

Filing Date: June 27, 2001

Group Art Unit: 2813

Title: PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR METAL CAPACITOR
IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

- (X) Response/Amendment () Petition to extend time to respond
() New fee as calculated below () Supplemental Declaration
(X) No additional fee
() Other: (fee \$)

CLAIMS AS AMENDED BY OTHER THAN A SMALL ENTITY						
(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT	(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	(6) RATE	(7) ADDITIONAL FEES
TOTAL CLAIMS	13	MINUS	20	= 0	X \$18	\$ 0
INDEP. CLAIMS	1	MINUS	3	= 0	X \$88	\$ 0
[] FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM					+ \$300	\$ 0
EXTENSION FEE	1ST MONTH \$110.00	2ND MONTH \$430.00	3RD MONTH \$980.00	4TH MONTH \$1530.00		\$ 0
OTHER FEES						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0

Charge \$ 0 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.

Respectfully submitted,

Osamu S. Nakagawa et al.

By 

Timothy B. Kang

Attorney/Agent for Applicant(s)
Reg. No. 46,423

Date: Nov. 24, 2004



PATENT
Atty Docket No.: 10004808-1

2813
JLW

U.S. Patent and Trademark Office

In Re the Application of:

Inventor(s): Osamu S. Nakagawa et al. **Confirmation No.:** 3635
Serial No.: 09/891,324 **Examiner:** Schillinger, Laura M.
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METAL CAPACITOR IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

MAIL STOP AMENDMENT

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CERTIFICATE OF HAND-DELIVERY WITH THE USPTO

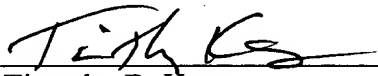
I hereby certify that this correspondence is being deposited with the United States Patent and Trademark Office. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment. (2 copies).
10 sheets of Request for Reconsideration.

Respectfully submitted,

MANNAVA & KANG, P.C.

On November 24, 2004


Timothy B. Kang
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HPNO: 10004808-1

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REQUEST FOR RECONSIDERATION

Sir:

Applicants respectfully submit this Request for Reconsideration in response to the Official Action mailed on August 25, 2004. Please find below a listing of all the pending claims for the convenience of the Examiner in considering this Request for Reconsideration. The Examiner is respectfully requested to consider the remarks following the listing of the pending claims.